

Application No.: 10/721,605  
Attorney Docket: MXIC 1516-1

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On March 23, 2004.

Signed: Paul H. Wang

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re application of: Chih-Hao Wang et al.	Attorney Docket No.: MXIC1516-1
Application No.: 10/721,605	Examiner: Unassigned
Filed: 25 November 2003	Group: 2811
Title: Method for Forming Oxide on Ono Structure	Confirmation No.: 5625
	Customer No. 22470

**INFORMATION DISCLOSURE STATEMENT**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

It is requested that the information identified in this statement be considered by the Examiner and made of record in the above-identified application. This statement is not intended to represent that a search has been made or that the information cited in the statement is, or is considered to be, material to patentability as defined in 37 C.F.R. 1.56.

Enclosed with this statement is a Form PTO/SB/08A. The Examiner is requested to initial the form and return it to the undersigned in accordance with M.P.E.P. 609.

Also enclosed with this statement is a copy of each cited document as required by 37 C.F.R. 1.98. However, since this application was filed after June 30, 2003, copies of U. S. Patents and U. S. Patent Application Publications are not enclosed. (See O. G. Notice of August 5, 2003.)

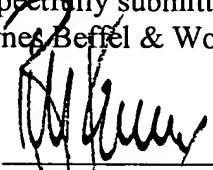
This statement should be considered under 37 C.F.R. 1.97(b) because it is being filed before the mailing date of the first Office Action on the merits.

**Fee Authorization.** The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 50-0869 (MXIC 1516-1). A duplicate copy of this authorization is enclosed.

Respectfully submitted,  
Haynes Beffel & Wolfeld LLP

Date: 23 March 2004

By:

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Bill Kennedy, Reg. No. 33,407

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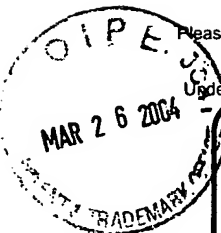
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Sheet	1	of	1		
				<b>Application Number</b>	10/721,605
				<b>Filing Date</b>	11/25/2003
				<b>First Named Inventor</b>	Chih-Hao Wang
				<b>Group Art Unit</b>	2811
				<b>Examiner Name</b>	Unassigned
				<b>Attorney Docket Number</b>	MXIC 1516-1

U.S. PATENT DOCUMENTS						
Examiner Initials*	Cite No. <sup>1</sup>	U.S. Patent Document		Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear
		Number	Kind Code <sup>2</sup> (if known)			
	A1	4,949,154		Haken	08-14-1990	
	A2	5,768,192		Eitan	06-16-1998	
	A3	5,966,603		Eitan	10-12-1999	
	A4	6,037,273		Gronet et al.	03-14-2000	
	A5	6,074,917		Chang et al.	06-13-2000	
	A6	6,159,866		Gronet et al.	12-12-2000	
	A7	6,171,911		Yu	01-09-2001	
	A8	6,184,155		Yu et al.	02-06-2001	
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	A11					
	A12					
	A13					
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FOREIGN PATENT DOCUMENTS								
Examiner Initials*	Cite No. <sup>1</sup>	Foreign Patent Document			Name of Patentee or Applicant of Cited Document	Date of Publication of Cited Document MM-DD-YYYY	Pages, Columns, Lines, Where Relevant Passages or Relevant Figures Appear	T <sup>6</sup>
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<b>Examiner Signature</b>		<b>Date Considered</b>	
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<sup>1</sup> Unique citation designation number. <sup>2</sup> See attached Kinds of U.S. Patent Documents. <sup>3</sup> Enter Office that issued the document, by the two-letter code (WIPO Standard ST.3). <sup>4</sup> For Japanese patent documents, the indication of the year of the reign of the Emperor must precede the serial number of the patent document. <sup>5</sup> Kind of document by the appropriate symbols as indicated on the document under WIPO Standard ST. 16 if possible. <sup>6</sup> Applicant is to place a check mark here if English language Translation is attached.

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